## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		)	Examiner: Christopher M Raabe Group Art Unit 2879 Confirmation No. 2864
TAKESHI ICHIKAWA ET AL.		)	
Application No.: 10/516,545 Filed: December 2, 2004		) : )	
For:	ELECTRON-EMITTING DEVICE AND MANUFACTURING METHOD THEREOF	; ) ; )	May 5, 2009

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

In response to the Office Action of February 5, 2009, please amend the above-identified application as follows.